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<b>TRANSMITTAL FORM</b>   Total number of pages in this submission	Application Number	10/605227
	Filing Date	09/16/2003
	First Named Inventor	Kangguo Cheng
	Group Art Unit	2822
	Examiner Name	K. L. Rose
	Attorney Docket No.	FIS920030221US1

**ENCLOSURES**

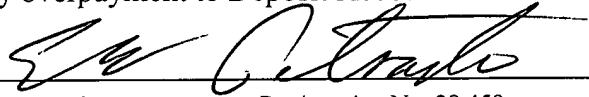
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<input checked="" type="checkbox"/>	Amendment	Declaration and Power of Attorney
<input type="checkbox"/>	After Final _____ Declarations	Drawings
<input type="checkbox"/>	Extension of Time Request	Petition
<input type="checkbox"/>	Express Abandonment Request	Power of Attorney (Associate)
<input type="checkbox"/>	Information Disclosure Statement	Terminal Disclaimer
<input type="checkbox"/>	Certified Copy of Priority Documents	Appeal
<input type="checkbox"/>	Response to Missing Parts - Incomplete	Status Letter
<input type="checkbox"/>	Response to Missing Parts - Under 37 CFR 11.52 or 1.53	Other

The Filing Fee has been calculated as shown below:

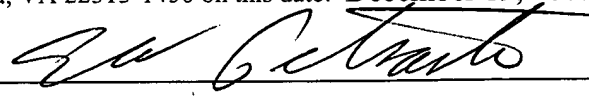
For:	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PAID FOR	Rate	Fee
Total Claims	14	20	\$50.	\$0.00
Indep Claims	2	3	\$200.	\$0.00
			Total	\$0.00

  X   Please charge Deposit Account No. 09/0458 of International Business Machines Corporation in the amount of \$0.00

  X   The Commissioner is hereby authorized to charge any additional fees required herewith or credit any overpayment to Deposit Account No. 09/0458


December 19, 2005  
 Eric W. Petraske
 Date

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, U.S. Patent and Trademark Office, Alexandria, VA 22313-1450 on this date: December 19, 2005

  
 Eric W. Petraske



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

<u>In re application of:</u> Kangguo Cheng	<u>Filed:</u> 09/16/2003
	<u>Examiner:</u> K. L. Rose
<u>Serial No.</u> 10/605227	<u>Group Art Unit:</u> 2822
<u>Title:</u> Method and Structure of Vertical Strained Silicon Devices	<u>Docket #:</u> FIS920030221US1

**PRELIMINARY AMENDMENT**

Commissioner of Patents & Trademarks  
Alexandria, VA 22313

Sir:

In response to the Action of 09/19/2005, please amend the above identified application as follows: